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GEMOLOGICAL  
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LABORATORY GROWN DIAMOND REPORT

September 5, 2024

IGI Report Number

LG651434592

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

9.30 X 6.60 X 4.28 MM

GRADING RESULTS

Carat Weight

2.57 CARATS

Color Grade

G

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG651434592

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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
Symmetry

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Fluorescence

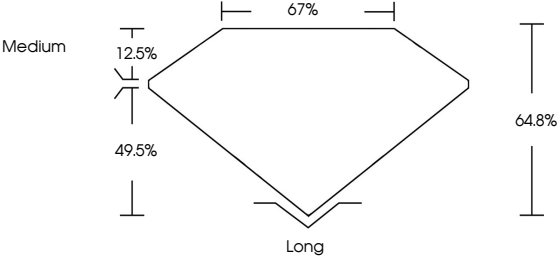
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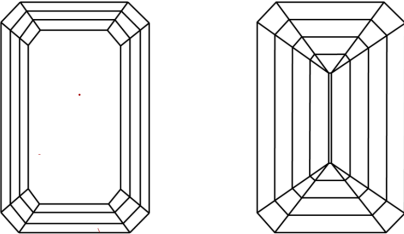
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS <sup>1-2</sup> VS <sup>1-2</sup> SI <sup>1-2</sup> I <sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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EMERALD CUT

9.30 X 6.60 X 4.28 MM

Carat Weight

2.57 CARATS

Color Grade

G

Clarity Grade

VVS 2

Depth

49.5%

Table

67%

Girdle

Medium

Culet

Long

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

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